IFW/

JAN 1 8 2005 LEARN TRADERIOR

Docket No. 0524-0139.01

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Applica	tion of:	)
Nozawa et al.		I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
Serial No.: 10/771,997		Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on
Filed: Februa	ary 4, 2004	January 13,2005 (Date of Deposit)
For: Manufacturing Method And Apparatus of Phase Mask Shift Blank		Shannon Wallace  Name of applicant, assignee or Registered Rep.
Examiner:	Steven Versteeg	) Signature Date
Art Unit:	1753	)

## **AMENDMENT A**

Commissioner of Patents P. O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action of September 13, 2004, a one month extension of time be being submitted herewith, please amend the above-identified application as follows: